

APR 20 2005

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Eric NYRET et al.

Confirmation no. 1950

Application No.: 10/784,040

Group Art Unit: 2825

Filed: February 20, 2004

Examiner: L. H. Malsawma

For: **PREVENTIVE TREATMENT METHOD
FOR A MULTILAYER SEMICONDUCTOR
WAFER**

Attorney Docket No.: 4717-10100

See Only

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Office Action dated April 6, 2005 regarding the above-identified application.

CLAIM AMENDMENTS are reflected in the listing of claims which begins on page 2 of this paper.

REMARKS begin on page 5 of this paper.

No fees are believed to be due for this submission. Should any fees be required, however, please charge such fees to **Winston & Strawn LLP** Deposit Account No. 50-1814.